The temperature dependent current-voltage characteristics of chemically prepared AL/(P)PBS Schottky barrier junction

L. Rajen Singh\textsuperscript{a*}, M. A. Hussain\textsuperscript{b}
\textsuperscript{a}Department of Physics, D. M. College of Science, Imphal-795001, Manipur, India
\textsuperscript{b}Department of Physics, Imphal College, Imphal-795130, Manipur, India

Zinc (Zn) doped nanocrystalline lead sulphide (PbS) thin film is prepared by chemical bath deposition (CBD) method at bath deposition temperature 313K using Zinc Acetate, Lead Acetate and Thiourea. The prepared films is characterized by X-ray diffraction (XRD), energy dispersive X-ray analysis (EDX), Scanning electron microscopy (SEM) and transmission electron microscopy (TEM) analysis. Al/(p)PbS Schottky barrier junctions are fabricated onto indium tin oxide (ITO) substrate to study the junction parameters. The Current-Voltage (I-V) characteristics of the junctions is measured in the temperature range of 303 to 333 K and various junction parameters are calculated. The ideality factor (n) and Schottky barrier height ($\Phi_b$) at different temperatures are found to vary from 5.31 to 4.47 and 0.749 eV to 0.755 eV respectively. The carrier concentration is determined from the capacitance-voltage (C-V) plot and found to be of the order $10^{16}$ cm$^{-3}$.

(Received November 4, 2021; Accepted February 19, 2022)

Keywords: Nanocrystalline, Thin film, Schottky barrier junctions, Ideality factor, Schottky barrier height

1. Introduction

Semiconducting materials are used in different solid state devices depending on their optical and electrical properties. The metal-semiconductor junctions are used as rectifiers, microwave diodes, UV detectors, switching diodes, photo sensors and solar cells [1-7]. Among the semiconductors compound, PbS is a narrow band gap semiconductor compound having a optical band gap of 0.41 eV in bulk form [8]. The energy band gap ($E_g$) of the nanocrystalline PbS compound can be tuned to anywhere between 0.41eV (bulk) to 4 eV [9]. For these reasons, many researchers have study this material by various deposition techniques such as spray pyrolysis [10], electro deposition [11, 12], microwave heating [13,14], successive ionic layer adsorption and reaction (SILAR) [15], vacuum evaporation [16], molecular beam epitaxy [17], chemical bath deposition [18-21] etc. Among the various techniques, chemical bath deposition method have several advantages as compared to other techniques such as uniform film deposition, inexpensive, convenient for large area deposition and do not require sophisticated instruments [22,23]. The dimensions of the crystallites and quality of the films can be controlled by varying the deposition parameters such as pH value, reaction time, deposition temperature, concentration of lead, Zinc and sulphur ions. The deposition conditions and techniques play a major role in the physical properties of Zn doped PbS thin films.

Metal-Semiconductor (MS) contacts are the most widely used rectifying contacts in the electronics industry [24-26]. The performance and reliability of a Schottky diode is drastically influenced by the interface quality between the deposited metal and semiconductor surface [27]. The detailed measurements of the physical parameters of the Schottky barrier formed at the interface of a semiconducting colloidal quantum dot film and a metal and the ideality factor 1.3 for the Al/PbS CQD Schottky devices were reported by Clifford et al. [28]. Debnath et al. [29] have reported a ITO/PbS CQD film/LiF/Metal Schottky device with fill factor 51% and efficiency 3.6%. Strasfeld et al.[30] fabricated planar PbS quantum dot devices with ohmic and Schottky

* Corresponding author: l_rajen03@yahoo.com
type electrodes and investigated the vast difference between the local photocurrents that arise due to Ohmic and Schottky contacts. However, there is very few literatures available on the properties of Al/(p)PbS Schottky junctions fabricated by CBD. Therefore, our main aim in this work is to study the structural and surface morphological characteristics of Zn doped PbS films and current-voltage characterization of Al/(p)PbS Schottky junction.

2. Experimental details

Zinc doped nanocrystalline PbS thin film is deposited onto chemically cleaned glass substrates and ITO glass substrates by CBD method using Zinc acetate, lead acetate and thiourea as Zn$^{+2}$, Pb$^{+2}$ and S$^{-2}$ sources respectively. For this, freshly prepared 0.2M solution of lead acetate (premixed with 4 wt. % Zinc acetate) and pH value of the solution was maintained at 11 by drop wise addition of NH$_3$ solution. Another equal amount of 0.2 M solution of thiourea was added and the solution mixture was stirred well. Bare glass substrates and ITO glass substrates are immersed vertically into the solution. The mixture solution is heated at 313 K for 1 hour and then kept at room temperature for 24 hr for further deposition. After deposition, the substrates coated with Zn doped PbS on both sides are taken out and thoroughly washed with distilled water and dried in air. The films deposited on the glass substrates are used for XRD, EDX, SEM and TEM studies. The structural characterization of the film is obtained by using X-ray diffraction (XRD) XPERT-PRO Philips diffractometer. Surface morphology of the film is studied using JEOL-JSM 6360. Transmission electron microscopy (TEM) of the Zn doped PbS sample is carried out using JEM-2100 to estimate particle size. Semiconductor-metal contacts are made by evaporating gold electrodes of area (2mm x 2mm) on the Zn doped PbS films deposited over ITO glass substrates as shown in Fig.5 (inset). A Schottky junction device in the configuration Al/(p)PbS/ITO was thus, obtained to study junction parameters. I-V characteristics in the temperature range 303-333 K were measured by using Keithley Electrometer (6514) and Rishabh multimeter (14S). The temperature on the sample surface was measured by Instron (IN-303) digital temperature controller using PT-100 sensor. C-V measurement was carried out using Systronics LCR-Q meter (928). The type of the Zn doped PbS semiconductor as found by hot probe method was p-type. For forward bias, the negative terminal of the voltage source is connected to the ITO glass while the positive terminal to the gold electrodes.

3. Results and discussion

3.1. Structural properties

The XRD patterns of nanocrystalline Zn doped PbS thin films deposited on the glass substrates are shown in Fig. 1. The diffraction peaks observed at 20 values of 25.826°, 29.736°, 42.892° and 50.773° correspond to (111), (200), (220) and (311) planes respectively which are in good agreement with the JCPDS data reference code no. 01-077-0244 [31]. Therefore, it has been concluded that the deposited PbS thin films are polycrystalline in nature with cubic structure. The orientation of the grain growth is preferably along (200) direction. The preferential orientation in the (200) direction has also been reported by Gadave et al. [32] for PbS films deposited by CBD at 80°C and by Puiso et al. [33] of SILAR deposited PbS films on Si substrates. The average crystallite size is calculated using Scherer’s equation [34]

$$D = \frac{0.94\lambda}{\beta \cos \theta}$$

where $k$ is a constant equal to 0.94, $\lambda$ is the wavelength of the x-ray used (CuK$_\alpha$ radiation, $\lambda = 1.5418\AA$), $\beta$ is the full width at half maximum (FWHM) of the dominant x-ray diffraction peak in
radian and θ is the diffraction angle of the dominant peak. The average crystallite size of the Zn doped PbS was found to be 15 nm.

![Fig. 1. XRD spectra of nanocrystalline Zn doped PbS thin film.](image)

### 3.2. Elemental analysis

To confirm the chemical composition of Zn doped PbS thin film, the elemental analysis of the samples were performed by Energy Dispersive X-ray Spectrometer (EDX). Fig. 2 shows a typical EDX spectrum of 4 wt.% Zn doped PbS thin film. The spectrum confirms that Pb, S and Zn atoms are present in the prepared film. The average atomic percentage of Pb, S and Mn are found to be 49.24, 54.98 and 5.78 respectively. The presence of Zn atoms in the spectra indicates that Zn atoms are incorporated with the PbS film. The extra peaks observed in the EDAX spectra correspond to some impurity elements like Mg, Si, Na, Ca which are due to glass substrate or the substrate holder used in the EDAX instrument [35-37]. These might also be due to presence of C and O due to exposure of the film to the atmosphere [38]. There is no source of these elements in the chemicals used for the Zn doped PbS film synthesis. We consider only the atomic % of Pb, S and Zn present in the spectra of doped sample neglecting the percentage of the other elements present in the spectra.

![Fig. 2. EDAX spectra of 4 wt.% Zn doped PbS thin prepared at concentration 0.2 M, pH value 11 and deposition temperature 313K.](image)

### 3.3. SEM and TEM studies

The surface morphology of nanocrystalline Zn doped PbS thin films based on SEM image analysis is shown in Fig. 3. It is observed that the film is dense, smooth, homogeneous without any pore and consisting of grains of unequal shapes and sizes.
Transmission electron microscopy (TEM) image of nanocrystalline Zn doped PbS thin films is shown in Fig. 4. It reveals small particles attach together as well as large particles having spherical shapes. The particles in dark colour shown in Fig. 4(a) are the nanocrystalline Zn doped PbS and the calculated particles size is found to be in the range of 8-10 nm which is in good agreement with the X-ray diffraction results. HRTEM is used to study the structure as well as to observe lattice images showing different orientations of the nanocrystals of Zn doped PbS. The HRTEM image shown in Fig. 4(b) exhibits lattice fringes with d-spacing of 0.28 nm corresponding to the (200) reflection of the PbS cubic phase. Selected area electron diffraction (SAED) image shown in Fig. 4(c) exhibits multiple diffractions rings with missing periodicity which is due to the random orientation of the particles.

3.4. I-V characteristics of the Schottky barrier junction

The prepared Zn doped PbS thin films is a p-type semiconductor as determined by the hot probe method. Gold electrode with a work function 4.08 eV is deposited above the PbS films to form Schottky Barrier Junction between Al and PbS film. The reverse bias condition refers for Al/(p) Mn doped PbS/ITO structure to a bias voltage across the junction with positive polarity connected to the p type Zn doped PbS film through ITO electrode making Ohmic contact at the back and negative polarity to counter electrode of barrier metal Al. Fig. 5 shows the energy band diagram of a typical Al/(p) Zn doped PbS Schottky barrier junction before and after formation of the contact.
Fig. 5. Energy band diagram of Al/(p)Zn doped PbS Schottky Barrier Junction (a) before contact and (b) after contact.

Fig. 6. I-V characteristics of a typical Al/(p) Zn doped PbS Schottky Barrier junction in dark and under illumination at room temperature (303K). The junction is formed to exhibit rectifying characteristics both in dark and under illumination (2500 lux). However, the characteristics under illumination shows photovoltaic effect and are more rectifying in nature.

Fig. 7. I-V characteristics of Al/(p)PbS Schottky Barrier Junction in dark at various temperatures.

Fig. 6 shows the I-V characteristics of the typical Al/(p) Zn doped PbS Schottky Barrier Junction in dark and under illumination at room temperature (303K). The junction is formed to exhibit rectifying characteristics both in dark and under illumination (2500 lux). However, the characteristics under illumination shows photovoltaic effect and are more rectifying in nature. Fig. 7 shows the I-V characteristics of the typical Al/(p)PbS Schottky Barrier Junction under dark at
various temperatures. It has been observed that beyond room temperature (303K), the current increases abruptly with voltage.

The non-linear forward bias current through a Schottky contact could be well described by the thermionic emission theory. According to thermionic emission theory, the current density in Schottky barrier diodes is given as

\[
J = J_o \exp \left( \frac{qV}{nkT} \left[ 1 - \exp \left( \frac{-qV}{kT} \right) \right] \right)
\]

where \(J_o\) is the saturation current density, \(k\) is the Boltzman constant, \(n\) is the ideality factor, \(T\) is the absolute temperature, \(q\) is the electron charge and \(V\) is the applied voltage. The saturation current density \(J_o\) can be written as

\[
J_o = A^* T^\frac{2}{3} \exp \left( -\frac{q\phi_b}{kT} \right)
\]

where \(A^*\) is the effective Richardson constant and \(\phi_b\) is the barrier height. The ideality factor \(n\) and the saturation current density \(J_o\) of a Schottky diode is calculated from the slope of the linear region of the forward bias and the straight line intercept of Fig.8 at \(V=0\). The equation for \(n\) can be expressed as

\[
n = \frac{q}{kT} \left[ \frac{dV}{d \left( \ln \left( \frac{J}{1 - e^{-qV/kT}} \right) \right)} \right]
\]

Fig. 8 shows the linear portions of the \(\ln \left( \frac{J}{1 - e^{-qV/kT}} \right)\) vs \(V\) plots of the typical Au/(n)PbS Schottky Barrier Junction at different temperatures ranging from 303K to 333K. The values of the saturation current density and ideality factor of the junctions at different temperatures are calculated from these plots and are given in Table 1.
The ideality factor ($n$) is observed to decrease while the saturation current density $J_o$ is found to increase with increase of temperature for the typical junction. The increase in saturation current with temperature is due to the fact the current transport mechanism is dominated by thermionic emission process (39). The calculated values of $J_o$ at different temperatures are used to draw $\ln(J_o/T^2)$ vs $T^{-1}$ (Richardson plot).

Fig. 9 shows such Richardson plot for the typical junction. Table 1 shows the calculated values of Richardson constant ($A^*$) and barrier heights of the typical junction. The barrier heights measured from these Richardson plots are found to increase 0.749 eV to 0.755 eV for the typical Al/(p)PbS Schottky Barrier Junction. The increase in barrier heights with temperature is due to the inhomogeneous distribution of barrier heights at the metal semiconductor interface (40).

Fig. 10. Plots of Ideality factor ($n$), Schottky Barrier Height ($\Phi_b$) with temperature ($T$) for the typical Al/(p)PbS Schottky Barrier Junction (a) as-prepared and (b) after heat treatment.

Fig. 11. Plot of $\ln I$ versus $V$ of Al/(p)PbS Schottky barrier junction at different temperature.
Fig. 10 shows temperature variation of the ideality factors (n), Schottky Barrier height ($\phi_b$) for the typical junction as-prepared and after heat treatment. It is observed that the Barrier height ($\phi_b$) increases with the increase of temperature while the diode ideality factor (n) decreases with the increase of temperature.

From the study, it is observed that both the Saturation current density ($J_o$) and the Barrier height ($\phi_b$) increases with the increase of temperature while the diode ideality factor (n) decreases with the increase of temperature.

3.5. Series resistance

The Plot of $lnI$ versus $V$ of Al/(p)PbS Schottky barrier junction at different temperatures deviate from the straight line as shown in Fig.11 and this is due to the presence of series resistance ($R_s$) associated with the region between the depletion region and Ohmic contact. Here the voltage drop across $R_s$ causes the actual voltage developed across the barrier region to be less than the applied voltage to the junction. The values of $R_s$ obtained by plotting $AV$ vs $I$ (as shown in Fig. 12) are given in Table 1. The series resistances so obtained are found to be in the order of KΩ. The decrease in value of $R_s$ with increasing temperature is due to an increase in the number of free charge carriers by bond breaking [41].

![Fig. 12. Plot of $I$ vs $AV$ plots) of the typical Al/(p)PbS Schottky barrier junction at different temperatures.](image)

![Fig.13. Plot of $C^2$ versus $V$ for Al/(p)PbS Schottky Schottky barrier junction at room temperature 303K.](image)
Table 1. Junction parameters of Al/(p)PbS junction at different temperatures.

<table>
<thead>
<tr>
<th>Temperature (K)</th>
<th>Saturation current density J_o (Acm(^{-2}))</th>
<th>Ideality factor (n)</th>
<th>Potential barrier height (\phi_b) (eV)</th>
<th>Series resistance (R_s) ((\Omega))</th>
<th>Carrier concentration (N_a) cm(^{-3})</th>
<th>Richardson Constant A* (Acm(^{-2})K(^{-2}))</th>
</tr>
</thead>
<tbody>
<tr>
<td>303</td>
<td>2.831 x 10(^{10})</td>
<td>5.31</td>
<td>0.749</td>
<td>644</td>
<td>6.65 x 10(^{16})</td>
<td>86</td>
</tr>
<tr>
<td>313</td>
<td>7.124 x 10(^{10})</td>
<td>5.18</td>
<td>0.751</td>
<td>242</td>
<td></td>
<td></td>
</tr>
<tr>
<td>323</td>
<td>16.819 x 10(^{10})</td>
<td>5.05</td>
<td>0.752</td>
<td>87</td>
<td></td>
<td></td>
</tr>
<tr>
<td>333</td>
<td>41.038 x 10(^{10})</td>
<td>4.47</td>
<td>0.755</td>
<td>36</td>
<td></td>
<td></td>
</tr>
</tbody>
</table>

3.6. C-V characteristics of the Schottky barrier junction

The reverse bias \(C^{-2}\) versus \(V\) plot of the Al/(p)PbS junction measured in the room temperature (303K) at a frequency of 1 KHz is shown in Fig.13.

The depletion layer capacitance in Schottky barrier diod is expressed as [41]

\[
C = \left(\frac{q\varepsilon_s N_a}{2}\right)^{\frac{1}{2}} \left(V_d - \frac{kT}{q}\right)^{-\frac{1}{2}}
\]  

(6)

where \(\varepsilon_s = 160\varepsilon_o\) is the permittivity of the PbS [42], \(\varepsilon_o = 8.854 \times 10^{-12}\) and \(N_a\) = acceptor density or the carrier concentration. Since, the diffusion potential, \(V_d = V_{bi} + V\), where \(V_{bi}\) is the diffusion potential at zero bias, the above expression for \(C\) may be written as

\[
C = \left(\frac{q\varepsilon_s N_a}{2}\right)^{\frac{1}{2}} \left(V_{bi} + V - \frac{kT}{q}\right)^{-\frac{1}{2}}
\]  

(7)

\[
\frac{1}{C^2} = \frac{2}{q\varepsilon_s N_a} \left(V_{bi} + V - \frac{kT}{q}\right)
\]  

(8)

\[
d \left(\frac{1}{C^2}\right) = d(C^{-2}) = \frac{2d(V)}{q\varepsilon_s N_a}
\]  

(9)

\[
N_a = \frac{2d(V)}{q\varepsilon_s d(C^{-2})}
\]  

(10)

The plot of \(C^{-2}\) versus \(V\), according to equation (9) will give a straight line with a slope

\[
\text{Slope} = \frac{2}{q\varepsilon_s N_a}
\]  

(11)

From eqn. (8), at \(C^{-2} = 0\), the intercept is

\[
V_i = -V_r = V_{bi} - \frac{kT}{q}
\]  


\[ V_{bi} = V_i + \frac{kT}{q} \]  \hspace{1cm} (12)

The diffusion potential, \( V_{bi} \), is determined by knowing \( V_i \) from the plot (Fig.13) and found to be 0.706 eV. The carrier concentration \( N_a \) obtained by using (10) is \( 6.65 \times 10^{16}/\text{cm}^3 \). As the barrier height \( \phi_b \) is the sum of the diffusion potential \( V_{bi} \) and \( \xi \), this can be calculated from the equations

\[ \xi = \frac{kT}{q} \ln \left( \frac{N_c}{N_a} \right) \]  \hspace{1cm} (13)

\[ \phi_b = V_i + \xi + \frac{kT}{q} \]  \hspace{1cm} (14)

where \( N_c = 2 \left( \frac{2\pi m_e^* kT}{\hbar^2} \right)^{3/2} \) is the effective density of states in the conduction band for PbS at room temperature, \( N_a \) is the doping concentration calculated from the slopes of \( C^2-V \) plots (Fig. 13), \( h \) is the Planck’s constant, \( k \) is the Boltzmann’s constant and \( m_e^* \) is the effective electron mass for PbS given by \( m_e^* = 0.080 m_o \) where \( m_o \) is the rest mass of electron [43]. Thus, the barrier height \( \phi_b \) obtained from the C-V plot is 0.77 eV. The barrier height \( \phi_b \) obtained from I-V measurements at room temperature is 0.75 which is lower than those obtained from C-V measurements. The difference may be due to the formation of an interfacial layer containing defects. Thus, interfacial capacitance and capacitance due to depletion layer are in series, thereby decreasing the total capacitance and as a result, \( C^2 \) increases. This increases the intercept of \( C^2 \) versus \( V \) plot and increases the barrier height which may be due to the transport mechanism in these diodes and it is of purely thermionic emission in nature. Another reason may be the lowering of barrier height by the image force due to current flow across the barrier. In view of the fact that the I-V method involves the flow of electrons from semiconductor to the metal, the barrier height determined from the I-V method will logically yield lower barrier heights than the C-V measurements [44].

4. Conclusions

Nanocrystalline Mn doped PbS thin film is prepared and deposited on ITO glass substrate by CBD method and Au/(n)Mn doped PbS Schottky Barrier junction is fabricated using Au electrode deposited by vacuum evaporation over the Mn doped PbS film on ITO glass substrate. SEM results reveal that the overall surface morphology of the film is fairly smooth and uniform. The films consist of particles of different shapes and sizes. The particle size determined from XRD and TEM are closely agreed. The current-voltage characteristics of the junction at different temperatures are investigated. The ideality factor decreases and the potential barrier height increases with increase in temperature. These observations have been ascribed to barrier in homogeneities at the metal-semiconductor interface. The calculated series resistance \( R_s \) at different temperature is found to be in the range from 644 \( \Omega \) to 36 \( \Omega \). The value of \( R_s \) decreases with increasing temperature due to increase in the number or density of free charge carriers by bond breaking. The barrier height determined from the C-V is larger than those obtained from I-V characteristics. The carrier concentration \( N_a \) obtained from the C-V is found to be in the order of \( 10^{16}/\text{cm}^3 \).
Acknowledgments

I express my gratitude to IIT, Guwahati, India for EDX analysis, Department of Physics, Manipur University, Manipur, India, Department of instrumentation & USIC, Gauhati University, Guwahati, India for providing XRD, SEM and lastly SAIF, NEHU, Shillong, India for TEM analysis.

References

[34] B. D. Cullity, Elements of X-ray Diffraction, Massachusetts: Addison-Wesley, 102 (1956).